

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor(s) : Franz LAERMER  
Serial No. : 10/519,724  
Filed : December 28, 2004  
For : DEVICE AND METHOD FOR THE PRODUCTION OF  
CHLORINE TRIFLUORIDE AND SYSTEM FOR  
ETCHING SEMICONDUCTOR SUBSTRATES USING  
THIS DEVICE  
Examiner : Rakesh Dhingra  
Art Unit : 1792  
Confirmation No. : 5180

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is electronically transmitted  
to the USPTO via the Office of electronic filing system on:  
Date: February 26, 2010  
Signature: /Kevin Kambo/  
Kevin Kambo

**AMENDMENT**

S I R:

In response to the Office Action of December 9, 2009, whose three-month response date is March 9, 2010, kindly amend the above-captioned application without prejudice as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.

While no fees are believed to be due, the Commissioner is authorized, as appropriate and/or necessary, to charge any fees or credit any overpayment to **Deposit Account No. 11-0600.**